

Electronic Acknowledgement Receipt

EFS ID:	1200048
Application Number:	10799146
Confirmation Number:	7933
Title of Invention:	Method of depositing an amorphous carbon film for etch hardmask application
First Named Inventor:	Yuxiang May Wang
Customer Number:	44257
Filer:	Steven Harry VerSteeg
Filer Authorized By:	
Attorney Docket Number:	008244/DSM/BCVD
Receipt Date:	13-SEP-2006
Filing Date:	12-MAR-2004
Time Stamp:	18:55:55
Application Type:	Utility
International Application Number:	

Payment information:

Submitted with Payment	no
------------------------	----

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment After Final	8244_RFOA_EF.pdf	196691	no	6

Warnings:	
Information:	
Total Files Size (in bytes):	196691
This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.	
New Applications Under 35 U.S.C. 111 If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.	
National Stage of an International Application under 35 U.S.C. 371 If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.	